Hierarchical resource management in grid computing

Korkhov, V.V.

Citation for published version (APA):

General rights
It is not permitted to download or to forward/distribute the text or part of it without the consent of the author(s) and/or copyright holder(s), other than for strictly personal, individual use, unless the work is under an open content license (like Creative Commons).

Disclaimer/Complaints regulations
If you believe that digital publication of certain material infringes any of your rights or (privacy) interests, please let the Library know, stating your reasons. In case of a legitimate complaint, the Library will make the material inaccessible and/or remove it from the website. Please Ask the Library: https://uba.uva.nl/en/contact, or a letter to: Library of the University of Amsterdam, Secretariat, Singel 425, 1012 WP Amsterdam, The Netherlands. You will be contacted as soon as possible.

UvA-DARE is a service provided by the library of the University of Amsterdam (http://dare.uva.nl)
Bibliography


[71] V. V. Krzhizhanovskaya, M. A. Zatevakhin, A. A. Ignatiev, Yuri E. Gorbachev, and Peter M. A. Sloot. Distributed Simulation of Silicon-Based Film Growth. In PPAM ’01: Proceedings of the th International Conference on Parallel Processing and Applied Mathematics- Revised Papers, pages 879–887, London, UK, 2002. Springer-Verlag.

[72] V.V. Krzhizhanovskaya and V.V. Korkhov. Problem-Solving Environments for Simulation and Optimization on Heterogeneous Distributed Computational Resources of the Grid. In Proceedings of the Third International Conference on Parallel Computations and Control Problems PACO’2006, Moscow, Russia. Publ: Moscow, V.A. Trapeznikov Institute of Control Sciences RAS, pp. 917-932, 2006.


[74] V.V. Krzhizhanovskaya, V.V. Korkhov, A. Tirado-Ramos, D.J. Groen, I.V. Shoshmina, I.A. Valuev, I.V. Morozov, N.V. Malysshkin, Y.E. Gorbachev, and P.M.A. Sloot. Computational Engineering on the Grid: Crafting a Distributed Virtual Reactor. In Second IEEE International Conference on e-Science and Grid Computing (e-Science’06), Amsterdam, the Netherlands, December 4-6 2006, pp.101. IEEE CS Press., 2006.

[75] V.V. Krzhizhanovskaya, P.M.A. Sloot, and Yu. E. Gorbachev. Grid-based Simulation of Industrial Thin-Film Production. Simulation: Transactions of the Society for Modeling and Simulation International, V. 81, No. 1, pp. 77-85, 2005.

[76] V.V. Krzhizhanovskaya, M.A. Zatevakhin, A.A. Ignatiev, Y.E. Gorbachev, W.J. Goedgeheer, and P.M.A. Sloot. A 3D Virtual Reactor for Simulation of Silicon-Based Film Production. In Proceedings of the ASME/JSME PVP Conference. ASME PVP-Vol. 491-2, pp. 59-68, PVP2004-3120, 2004.


